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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/747,737	12/29/2003	Todd Bailey	21554-0042002	2048
²⁶²⁰¹ FISH & RICH <i>A</i>	7590 06/02/200 ARDSON P.C.	EXAMINER		
P.O BOX 1022		LUK, EMMANUEL S		
Minneapolis, MN 55440-1022			ART UNIT	PAPER NUMBER
			1791	
			NOTIFICATION DATE	DELIVERY MODE
			06/02/2009	ELECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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PATDOCTC@fr.com

	Application No.	Applicant(s)
	10/747,737	BAILEY ET AL.
Office Action Summary	Examiner	Art Unit
	EMMANUEL S. LUK	1791
The MAILING DATE of this communication ap Period for Reply	opears on the cover sheet with the	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPOWHICHEVER IS LONGER, FROM THE MAILING IT Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period. Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATIO .136(a). In no event, however, may a reply be tild d will apply and will expire SIX (6) MONTHS from the, cause the application to become ABANDONE	N. mely filed I the mailing date of this communication. ED (35 U.S.C. § 133).
Status		
Responsive to communication(s) filed on 14 and 2a) This action is FINAL . 2b) The 3) Since this application is in condition for allowed closed in accordance with the practice under	is action is non-final. ance except for formal matters, pr	
Disposition of Claims		
4) Claim(s) 1-18 is/are pending in the applicatio 4a) Of the above claim(s) is/are withdres 5) Claim(s) is/are allowed. 6) Claim(s) 1-18 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/	awn from consideration. /or election requirement.	
9) The specification is objected to by the Examir 10) The drawing(s) filed on is/are: a) according a control and applicant may not request that any objection to the Replacement drawing sheet(s) including the corresponding to the corresponding to the corresponding and the corresponding to the cor	ccepted or b) objected to by the e drawing(s) be held in abeyance. Se ction is required if the drawing(s) is ob	e 37 CFR 1.85(a). ejected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documer 2. Certified copies of the priority documer 3. Copies of the certified copies of the priority application from the International Bures * See the attached detailed Office action for a list	nts have been received. nts have been received in Applicat ority documents have been receiv au (PCT Rule 17.2(a)).	ion No ed in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other:	ate

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DETAILED ACTION

Status of Claims

1. Status of Claims: Claims 1-18 are pending.

2. The Request for Continued Examination of the application is acknowledged.

Claim Rejections - 35 USC § 103

- 3. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
- 4. Claims 1, 2, 5-8, 10-15, 17, and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Heidari (2003/0159608) in view of Hector (5804017), Aoyama (5194743) and Doran (5716742).

Heidari teaches a lithography device for structure of the nanometer size (see Abstract), the device having a body 3 with an opening formed between the ring 11b, the body further having a vacuum supporting plate 14 having vacuum connections 20, wherein template 10 is held in place.

Heidari fails to teach a transparent support plate and a piezo system.

Hector teaches a flexible stamper 20 that is held in position by a body 28 with opening and further having a transparent plate 18 behind the stamper that allows for a UV source 42 to shine through. Hector is relevant to the arts as it relates to the imprinting arts as the stamper is pressed into a substrate of curable polymer.

Aoyama teaches the positioning of a stage using an X-Y stage 100 that is positioned while holding the substrate wit servo control and the positioning operations are read through X and Y digital micrometers 12, 16, Col. 19, 56-64. While Aoyama

pertains to the manufacturing of semiconductor wafers W, it is relevant to one skilled in the art due to the adjustments to the stage for alignment.

Doran teaches an alignment system that utilizes piezoelectric actuators 44, 46, 48 for adjusting the position of the X-Y stage 32. The use of piezoelectric actuators as a piezo system for controlling the X-Y stage is well known for use in alignment of a wafer or workpiece. One of ordinary skill in the art would have recognized the use the of piezoelectric actuators in alignment of wafers and thus can be applied to the X-Y stage of Aoyama and for aid in positioning other stages including a stamper taught by Hector and the device taught by Heidari.

It would have been obvious for one of ordinary skill in the art to modify Heidari with a transparent support plate taught by Hector thereby allowing for the material worked upon to be cured by the UV source during imprinting operation and the alignment system taught by Aoyama for aligning the stage and piezo system as taught by Doran since the actuators can be substituted for the same results in positioning the body.

5. Claims 3, 4, 9, and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Heidari (2003/0159608) in view of Hector (5804017), Aoyama (5194743) and Doran (5716742) as applied to claims 1, 2, 5-8, 10-15, 17, and 18 above, and further in view of Semiconductor Memories (see IDS).

Heidari in view of Hector, Aoyama, and Doran fails to teach the supporting plate is formed from silicon dioxide.

Semiconductor Memories teaches the use of Silicon Dioxide as backing support for the silicon wafer (see page 91).

It would have been obvious for one of ordinary skill in the art to modify Heidari in view of Hector to use silicon dioxide as taught by Semiconductor Memories since it is a known transparent material used in the arts that allows for materials to cure.

Response to Arguments

6. Applicant's arguments with respect to claims 1-18 filed on 5/14/09 have been considered but are not persuasive. The applicants have included amended features utilizing a piezo system for changing the dimensions of the body, this broadly interpreted includes maneuvering the piece in an X-Y direction as for alignment and this is known in the lithography arts. New references, Doran and Aoyama, have been incorporated with Heidari in view of Hector for addressing the claimed invention.

Conclusion

- 7. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Van Den Brink 5801832 and Murouchi 6036568.
- 8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to EMMANUEL S. LUK whose telephone number is (571)272-1134. The examiner can normally be reached on Monday-Fridays from 9 to 5.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Yogendra N. Gupta can be reached on (571) 272-1316. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Yogendra N Gupta/ Supervisory Patent Examiner, Art Unit 1791

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